

AF 2800  
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Charles M. McKenna et al.  
Serial No: 09/602,059  
Confirmation No: 9493  
Filed: June 23, 2000  
For: ION IMPLANTER HAVING TWO-STAGE DECELERATION  
BEAMLINE  
Examiner: Mary A. El-Shammaa  
Art Unit: 2881

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

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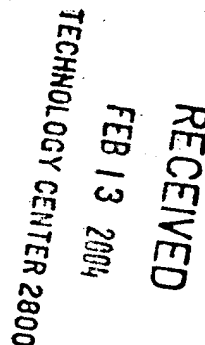
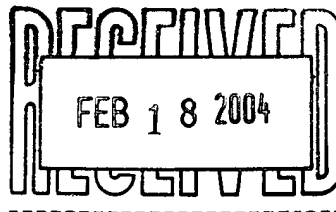
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Sir:

Transmitted herewith are the following documents:

- ☒ Response to Final
- ☒ Three-month Petition for Extension of Time
- ☒ Notice of Appeal
- ☒ Return Receipt Postcard



If any fees are determined to be required or if there are any overpayments, Deposit Account 50-0896 may be charged or credited.

Respectfully submitted,  
Charles M. McKenna et al. , Applicants

By:

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